

Docket Number
36856.1455

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Hiroyuki KANBARA et al. Serial No.: Currently unknown Filing or 371(c) Date: Concurrently herewith Title: METHOD FOR FORMING THICK FILM PATTERN, METHOD FOR MANUFACTURING ELECTRONIC COMPONENT, AND PHOTOLITHOGRAPHY PHOTOSENSITIVE PASTE	International Application No.: PCT/JP2004/015621 International Filing Date: October 21, 2004
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PRELIMINARY AMENDMENT

Mail Stop PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination on the merits of the above-identified patent application,
Applicants respectfully request entry and consideration of the following Amendment:

- ☒ **Amendments to the Specification** begin on page 2 of this paper.
- ☐ **Amendments to the Drawings** begin on page of this paper and include an attached replacement sheet.
- ☒ **Amendments to the Claims** are reflected in the listing of the claims which begins on page 5 of this paper.
- ☒ **Remarks/Arguments** begin on page 10 of this paper.

Please note, if a box is not checked, then no corresponding amendment is being made.